



Contribution ID: 590

Type: **not specified**

Development of HVCMOS in 55 nm Process for Tracing [Zoom]

Thursday 18 January 2024 09:30 (30 minutes)

My talk would be conducted

Scheduling Preferences

Author: LI, Yiming (IHEP; Via Zoom)

Presenter: LI, Yiming (IHEP; Via Zoom)

Session Classification: Mini-workshop: Experiment/Detector